

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

In re Application of:

Tsung et al.

Serial No.: 09/921,324

Filed: 08/02/01

For: MASS PRODUCTION OF CROSS-SECTION TEM SAMPLES BY
FOCUSED ION BEAM DEPOSITION AND ANISOTROPIC ETCHING

Docket: TI-30243

Art Unit: 2823

Examiner: G. Fourson III

Assistant Commissioner for
Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING 37 CFR §1.8(a)

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Jackie McBride

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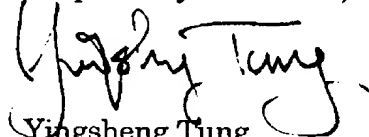
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Sir:

In response to the Examiner's restriction requirement (Paper No. 3) mailed October 31, 2002, Applicants hereby elect to pursue Group II, Claims 13-16 for examination purposes.

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Respectfully submitted,


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Examiner: J. Chen

For: **MASS PRODUCTION OF CROSS-SECTION TEM SAMPLES BY FOCUSED ION BEAM DEPOSITION AND ANISOTROPIC ETCHING**

CERTIFICATION OF FACSIMILE TRANSMISSION

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<table border="1"> <tr> <td colspan="2">NAME OF INVENTOR(S): Tsung et al.</td> <td colspan="2">RECEIPT DATE & SERIAL NO. Serial No.: 09/921,324</td> </tr> <tr> <td colspan="2">TITLE OF INVENTION: Mass Production of Cross-Section TEM Samples by Focused Ion Beam...</td> <td colspan="2"></td> </tr> <tr> <td>TI FILE NO.: TI-30243</td> <td>DEPOSIT ACCT. NO.: 20-0668</td> <td colspan="2"></td> </tr> <tr> <td colspan="2">FAXED: 11/08/2002 DUE: 11/30/2002</td> <td colspan="2"></td> </tr> <tr> <td colspan="2">ATTY/SEC'Y: YT/jsm</td> <td colspan="2"></td> </tr> </table>		NAME OF INVENTOR(S): Tsung et al.		RECEIPT DATE & SERIAL NO. Serial No.: 09/921,324		TITLE OF INVENTION: Mass Production of Cross-Section TEM Samples by Focused Ion Beam...				TI FILE NO.: TI-30243	DEPOSIT ACCT. NO.: 20-0668			FAXED: 11/08/2002 DUE: 11/30/2002				ATTY/SEC'Y: YT/jsm			
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